

Appl. No. 10/006,398
 Amendment dated January 07, 2004
 Reply to Office Action of October 8, 2003

Docket No. 01-234

#4
 Amata
 TV 3-25-04

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: : Colin D. Yates, Nicholas F. Pasch, and Nicholas K. Eib
 Appl. No. : 10/006,398
 Filed: : November 30, 2001
 Title : ALIGNMENT PROCESS FOR INTEGRATED CIRCUIT
 STRUCTURES ON SEMICONDUCTOR SUBSTRATE USING
 SCATTEROMETRY MEASUREMENTS OF LATENT IMAGES IN
 SPACED APART TEST FIELDS ON SUBSTRATE
 Grp./ A.U. : 2877
 Examiner : Layla G. Lauchman
 Docket No. : 01-234

CERTIFICATE OF MAILING	
I hereby certify that this amendment is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below:	
on	<u>January 07, 2004</u> (Date of Mailing)
John P. Taylor, Reg. No. 22,369	
	<u>John P. Taylor</u> Signature
	<u>January 07, 2004</u> Date of Signature

AMENDMENT

Honorable Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Date: January 07, 2004

Sir:

In response to the Office Action of October 8, 2003, please amend the above-identified application as follows: